



ABSTRACT

PROCESS FOR DETACHING LAYERS OF MATERIAL

A process of detachment of two layers of material according to an embrittlement surface defined between the two layers, the process comprising thermal annealing of a structure comprising said layers, said annealing bringing the temperature from a starting temperature to a final annealing temperature, characterised in that during the thermal annealing the annealing temperature is made to evolve according to a first phase up to a transition temperature, then according to a second phase during which the rise in temperature per unit of time is stronger than during the first phase.

The invention also concerns an application for using this process.

(Figure 5)